



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER OF PATENTS AND TRADEMARKS  
Washington, D.C. 20231  
www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/902,882	08/24/2001	Joachim Sacher	Sacher II-Div	1028

7590

09/30/2002

Klaus J. Bach  
4407 Twin Oaks Drive  
Murrysville, PA 15668

EXAMINER

MOORE, KARLA A

ART UNIT

PAPER NUMBER

1763

DATE MAILED: 09/30/2002

7

Please find below and/or attached an Office communication concerning this application or proceeding.

## Office Action Summary

Application No.

09/902,882

Applicant(s)

SACHER, JOACHIM

Examiner

Karla Moore

Art Unit

1763

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

### Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).
- Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

### Status

- 1) ☐ Responsive to communication(s) filed on \_\_\_\_\_.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

### Disposition of Claims

- 4) ☒ Claim(s) 14-20 is/are pending in the application.
- 4a) Of the above claim(s) \_\_\_\_\_ is/are withdrawn from consideration.
- 5) ☐ Claim(s) \_\_\_\_\_ is/are allowed.
- 6) ☒ Claim(s) 14-20 is/are rejected.
- 7) ☐ Claim(s) \_\_\_\_\_ is/are objected to.
- 8) ☐ Claim(s) \_\_\_\_\_ are subject to restriction and/or election requirement.

### Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☒ The drawing(s) filed on 12 July 2001 and 24 August 2001 is/are: a) ☒ accepted or b) ☐ objected to by the Examiner  
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
- 11) ☐ The proposed drawing correction filed on \_\_\_\_\_ is: a) ☐ approved b) ☐ disapproved by the Examiner.  
If approved, corrected drawings are required in reply to this Office action.
- 12) ☐ The oath or declaration is objected to by the Examiner.

### Priority under 35 U.S.C. §§ 119 and 120

- 13) ☒ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  
a) ☐ All b) ☐ Some \* c) ☒ None of:  
1. ☒ Certified copies of the priority documents have been received.  
2. ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.  
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).  
\* See the attached detailed Office action for a list of the certified copies not received.
- 14) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).  
a) ☐ The translation of the foreign language provisional application has been received.
- 15) ☒ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.

### Attachment(s)

- 1) ☒ Notice of References Cited (PTO-892)
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- 3) ☐ Information Disclosure Statement(s) (PTO-1449) Paper No(s) \_\_\_\_\_
- 4) ☐ Interview Summary (PTO-413) Paper No(s). \_\_\_\_\_
- 5) ☐ Notice of Informal Patent Application (PTO-152)
- 6) ☐ Other: \_\_\_\_\_

Art Unit: 1763

## DETAILED ACTION

### *Priority*

1. Acknowledgment is made of applicant's claim for foreign priority based on an application filed in Germany on 03/21/98. It is noted, however, that applicant has not filed a certified copy of the German application as required by 35 U.S.C. 119(b). Examiner checked the parent Application 09/263,481 for the document, as well, it did not contain a certified copy, either.

### *Information Disclosure Statement*

2. The listing of references in the specification is not a proper information disclosure statement. 37 CFR 1.98(b) requires a list of all patents, publications, or other information submitted for consideration by the Office, and MPEP § 609 A(1) states, "the list may not be incorporated into the specification but must be submitted in a separate paper." Therefore, unless the references have been cited by the examiner on form PTO-892, they have not been considered.

### *Claim Rejections - 35 USC § 112*

3. The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

4. Claim 17 rejected under 35 U.S.C. 112, first paragraph, as based on a disclosure which is not enabling. See *In re Mayhew*, 527 F.2d 1229, 188 USPQ 356 (CCPA 1976). While the specification and drawings do disclose lasers to be coated in a linear arrangement, the specification and the drawings fail to disclose a "linear" coating source.

5. The following is a quotation of the second paragraph of 35 U.S.C. 112:

Art Unit: 1763

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

6. Claim 20 recites the limitation "said shutter support structure". There is insufficient antecedent basis for this limitation in the claim.

***Claim Rejections - 35 USC § 103***

7. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

8. Claims 14-16 and 18-20 are rejected under 35 U.S.C. 103(a) as being unpatentable over U.S. Patent No. 6,037,006 to Chakrabarti et al. in view of U.S. Patent No. 5,221,636 to Landreau et al.

9. Chakrabarti et al. discloses an apparatus for coating at least one of the front and rear facets of semiconductor laser diodes (lasers) with an anti-reflection layer, substantially as claimed. The apparatus comprises: a receiver (Figure 10, 160) for containing lasers; a coating source (170) disposed in said receiver; and a support structure (164) for supporting said lasers to be coated such that said lasers are supported with their facets all at essentially the same distance from said coating source.

10. Further, in the apparatus of Chakrabarti et al, said lasers are supported on a support structure forming a magazine (150) by which they can be moved into, and out of, said receiver (column 5, rows 59-62 and column 6, rows 60-63). Additionally, said lasers are arranged in a circle around said coating source in Figure 8, although the source is not at the center of the circle.

11. However, Chakrabarti et al. fail to teach in-situ monitoring of a least one of the laser parameters including the laser light emitted, electric voltage, quantum efficiency or threshold

Art Unit: 1763

current. Nor, does Chakrabarti teach at least one shutter supported in said receiver so as to be movable selectively in front of at least one of said lasers to protect it from further coating.

Chakrabarti also fail to teach use of a control unit which monitors the laser parameter of at least one of the lasers disposed in said receiver for the coating of their facets while said at least one laser is electrically operated. The control unit including at least one of a laser control, shutter control, a layer thickness control and a vacuum control arrangement and said control unit communicating with said coating source, said laser support and said shutter support structure by at least one of electrical and optical conduits.

12. Landreau et al. teach use of a voltmeter (column 3, rows 34-37) for in-situ monitoring of the electrical voltage of the laser for the purpose of detecting a maximum voltage, which indicates an overall reflectivity minimum of a coating applied and thus provides a stopping point for the coating process (column 2, rows 14-27).

13. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided in-situ monitoring of at least one of the laser parameters, such as electric voltage in Chakrabarti et al. in order to determine an overall reflectivity minimum of a coating applied and thus a stopping point for the coating process as taught by Landreau et al.

14. Additionally, Landreau et al. teach use of a retractable shutter (23) for protection of the laser while a laser support is pivoted (column 3, rows 60-62).

15. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided a shutter in Chakrabarti et al. in order to protect a laser from coating when needed, such as during pivoting, as taught by Landreau et al.

16. Landreau et al. also teach the use of a control unit (32) which monitors a laser parameter (i.e. electric voltage) of at least one of the lasers in said receiver for the coating of their facets while said at least one laser is electrically operated. Said control unit includes a shutter control and a layer thickness control (column 3, rows 46-62). Said control unit is in communication with the coating source (S1), said laser support (S3) and a shutter support structure (S4) (Figure 1; column 3, rows 28-31). The control unit is provided for the purpose of detecting the instant where

Art Unit: 1763

said voltage passes through a maximum and controlling the stopping of the coating means (column 3, rows 43-45).

17. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided a control unit un Chakrabarti et al. in order to detect the instant where said voltage passes through a maximum and to control the stopping of the coating means as taught by Landreau et al.

18. Claim 17 is rejected under 35 U.S.C. 103(a) as being unpatentable over Chakrabarti et al. and Landreau et al. as applied to claims 14-16 and 18-20 above, and further in view of U.S. Patent No. 5,980,975 to Nomura et al.

19. Chakrabarti et al. and Landreau et al. disclose the invention substantially as claimed.

20. However, the prior art fails to teach arrangement of said lasers along lines disposed at opposite sides equidistantly from a coating source.

21. Nomura et al. teach placement of substrates (Figure 8, 10) disposed on opposite sides equidistantly from a coating source (9, column 11, rows 39-40) for the purpose exposing them simultaneously to film formation (column 12, rows 35-45).

22. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided the substrates on opposite sides and equidistant from a coating source in the prior art in order to simultaneously form a film on the substrates as taught by Nomura et al.

### **Conclusion**

23. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Karla Moore whose telephone number is 703.305.3142. The examiner can normally be reached on Monday-Friday, 8:30am-5:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Mills can be reached on 703.308.1633. The fax phone numbers for the

Art Unit: 1763

organization where this application or proceeding is assigned are 703.872.9310 for regular communications and 703.872.9311 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703.308.0661.

km

September 25, 2002

  
GREGORY MILLS  
SUPERVISORY PATENT EXAMINER  
TECHNOLOGY CENTER 1700